Attorney Docket No. TT4314

STATES PATENT AND TRADEMARK OFFICE

In re Application of:

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Christopher L. Wooten, et al.

Group Art Unit: 2623

NOV 2 6 2004

Serial No.: 09/976,739

Examiner: Kevin Siangchin Technology Center 2000

Filed: October 11, 2001

Title: METHOD FOR EVALUATING ANOMALIES IN A SEMICONDUCTOR

MANUFACTURING PROCESS

INFORMATION DISCLOSURE STATEMENT RECEIVED TO 1700

Mail Stop Amendment **Commissioner for Patents** P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Attached hereto is a completed Form PTO-1449 listing patents, publications, or other information which the applicant believes may be material to the examination of this application. It is requested that the cited patents be made of record in the examination of this application.

Respectfully submitted,

Dated: 19 November 2004

Bv

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CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this document (and any as referred to as being attached or enclosed) is being deposited with sufficient postage as first class mail with the United States Postal Service on 19 November. 2004 and addressed to Commissioner for Patents, Mailstop Amendment, P.O. Box 1450, Alexandria, VA 22313-1450.

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

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Sheet 1 of 1

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			Christopher L. Wooten, et al.		
(Use several sheets if necessary)		FILING DATE October 11, 2001			GROUP 2623
		U.S. PATENT DOCUME	NTS		
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5,507,933	01/14/03	Kirsch, et al.		Alex.	a a a a a a a a a a a a a a a a a a a
,831,865	11/03/98			16.	Elva
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